RECORDATION FORM COVER	SHEET	Docket Number ATMI-686-CIP
TO THE HONORABLE COMMISSIONER (OF PATENTS AND TRA	DEMARKS:
Please record the attached original docume	ent or copy thereof.	
Name of conveying party (ies):	2. Name and address of receiving party:	
Michael B. Korzenski Thomas H. Baum Chongying Xu Eliodor G. Ghenciu	Advanced Technology Materials, Inc. 7 Commerce Drive Danbury, Connecticut 06810	
Additional name(s) of conveying party (ies) attached? □ Yes ☒ No	Additional name(s) and addresses attached? □ Yes ☒ No	
3. Nature of conveyance:		
☑ Assignment ☐ Merger ☐ Security	Agreement	
□ Other		
Execution Date: <u>2/19/2004</u> , <u>2/18/2004</u> , <u>2/18/</u>	2004, 2/28/2004	
4. Application number(s) or patent number(s	s): <u>U.S. Serial No. 10/782</u>	2,355
If this document is being filed together wi application is:	th a new application, the	execution date of the
A. Patent Application No.(s)	B. Patent No.(s)	
Additional number	s attached? □ Yes □ N	0
Name and address of party to whom correspondence concerning document	7. Total Fee (37 CFR	3.41): \$ 40
should be mailed:	☐ Enclosed	
William F. Ryann, Esq. Advanced Technology Materials, Inc. 7 Commerce Drive Danbury, Connecticut 06810 Telephone: 203-794-1100	☑ Authorized to be account	charged to deposit
6. Total number of applications and patents involved: 1	8. Deposit account n 50-0860	umber:
DO NOT USE	THIS SPACE	
9. Statement and signature. To the best of my knowledge and belief, the for any attached copy is a true copy. Date	<u>Margart</u> Margaret	nue and correct and Chappus Chappuis 3. 45,735

PATENT

700087416 **REEL: 014672 FRAME: 0246**

Docket No.: 2771-686-CIP

ASSIGNMENT

We, MICHAEL B. KORZENSKI, THOMAS H. BAUM, CHONGYING XU, and ELIODOR G. GHENCIU have made an invention the specification of which is described in U.S. Utility Patent Application filed herewith in the U.S. Patent and Trademark Office, entitled:

"REMOVAL OF MEMS SACRIFICAL LAYERS USING SUPERCRITICAL FLUID/CHEMICAL FORMULATIONS"

We hereby assign to Advanced Materials Technology, Inc., 7 Commerce Drive, Danbury, CT 06810, all of our ownership and rights in:

- (i) the invention and U.S. Utility Patent Application;
- (ii) continuing, divisional and continuation-in-part applications based on and claiming priority of said U.S. Utility Patent Application;
- (iii) U.S. Patents on the invention; and
- (iv) corresponding foreign patent applications and patents.

We are making this assignment based on our employment relationship with Advanced Materials Technology, Inc.

We request the Commissioner of Patents and Trademarks of the United States and the appropriate officers of all foreign countries to issue patents on the invention to:

Advanced Materials Technology, Inc.

as owners of the invention and aforementioned patent rights.

We agree to execute any other legal documents that may be required to effectuate this Assignment.

We agree that we will promptly communicate to Advanced Materials Technology, Inc., all facts which come to our attention affecting the invention or patent rights.

We agree that we will testify in any interference or litigation involving the invention or patent rights.

We declare that we have not done anything in conflict with this Assignment.

Page 1 of 2

Docket No.: 2771-686-CIP

MICHAEL B. KORZENSKI DATE

Thomas # Dawn 2-18-04
DATE

ELIODOR G. GHENCIU

DATE

Docket No.: 2771-686-CIP

ASSIGNMENT

We, MICHAEL B. KORZENSKI, THOMAS H. BAUM, CHONGYING XU, and ELIODOR G. GHENCIU have made an invention the specification of which is described in U.S. Utility Patent Application filed herewith in the U.S. Patent and Trademark Office, entitled:

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Page 1 of 2

Docket No.: <u>2771-686-CIP</u>

MICHAEL B. KORZENSKI	DATE	
THOMAS H. BAUM	DATE	

CHONGYING XU DATE

ELIODOR G. GHENCIU

RECORDED: 05/26/2004

02/28/200

DATE

Page 2 of 2